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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Xu, Frank Y.

App. No.: 10/763,885 GPAU: 1752

Filing Date: January 23, 2004 Examiner: Amanda C. Walke

Dkt. No.: P113-55-03 Conf. No.: 6002

For: Materials and Methods for Imprint Lithography

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**INFORMATION DISCLOSURE STATEMENT**

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to the Examiner's attention in the above-identified application. It is respectfully requested that the cited information be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed:  
before the mailing date of a first Office action on the merits or before the mailing date of a first Office action after the filing of a request for continued examination under § 1.114. Therefore, no fee is believed required.

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Signed: Katrina Prati  
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Respectfully Submitted,



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Substitute for form 1449A/PTO

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<b>APPLICATION NUMBER</b>	10/763,885
<b>FILING DATE</b>	01/23/2004
<b>FIRST NAMED INVENTOR</b>	Xu et al.
Group Art Unit	1752
Examiner Name	Walke, Amanda C.
Attorney Docket Number	P113-55-03

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 1 of 5

### U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
C1	6,391,217	B2		Schaffer et al.	5/21/2002	
C2	2004/0007799	A1		Choi et al.	1/15/2004	
C3	2004/0021254	A1		Sreenivasan et al.	2/5/2004	
C4	2004/0021866	A1		Watts et al.	2/5/2004	
C5	2004/0022888	A1		Sreenivasan et al.	2/5/2004	
C6	2002/0177319	A1		Chou	11/28/2002	
C7	6,518,189	B1		Chou	2/11/2003	
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C13	2004/0137734	A1		Chou et al.	7/15/2004	
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C17	2003/0080472	A1		Chou	5/1/2003	
C18	2003/0034329	A1		Chou	2/20/2003	

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C19	2002/0042027	A1		Chou et al.	4/11/2002	
C20	5,594,042			Glover et al.	1/14/1997	
C21	5,629,095			Bujanowski et al.	5/13/1997	
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C34	5,849,222			Jen et al.	12/15/1998	

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				<b>FIRST NAMED INVENTOR</b>	Xu et al.
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				Examiner Name	Walke, Amanda C.
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<b>OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS</b>		
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
		T <sup>2</sup>

C41	Colburn et al., Step and Flash Imprint Lithography for sub-100 nm Patterning, Proceedings of SPIE Vol. 3997, pp. 453 - 457, 1/1/2000
C42	Papirer et al., The Grafting of Perfluorinated Silanes onto the Surface of Silica: Characterization by Inverse Gas Chromatography, Journal of Colloid and Interface Science 159, pp.238-242, 8/1/1993
C43	Chou et al., Nanoimprint Lithography, Journal of Vacuum Science Technolgy B 14(16), pp. 4129-4133, 11/1/1996
C44	Colburn et al., Development and Advantages of Step-and-Flash Lithography, Solid State Technology, 7/1/2001
C45	Colburn et al., Characterization and Modeling of Volumetric and Mechanical Properties for Step and Flash Imprint Lithography Photopolymers, Journal of Vacuum Science Technology. Vol b. 19(6), 11/1/2001
C46	Yu et al., Properties of Fluorinated Amorphous Diamond Like Carbon Films by PECVD, Applied Surface Science 219 (3-4); pp. 228-237, 12/1/2003
C47	Compon et al., Electroanalysis at Diamond-Like and Doped-Diamond Electrodes, Electroanalysis 15(17); pp. 1349-1363, 9/1/2003
C48	Mansano et al., Protective Carbon Layer for Chemical Corrosion of Stainless Steel, Diamond and Related Materials 12 (3-7); pp. 749-752, 3/1/2003
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials\*      Cite No.<sup>1</sup>      Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

	C50	Hakovirta et al., Heat Resistance of Fluorinated Diamond-Like Carbon Films, Diamond and Related Materials 10(8); pp. 1486-1490, 8/1/2001	
	C51	Zhu et al., The Improvement of the Oxidation Resistance of TiAl Alloys by Fluorine Plasma-Based Ion Implantation, Surface and Coatings Technology 158; pp. 502-507, 9/1/2002	
	C52	Yao et al., Structural, Mechanical and Hydrophobic Properties of Fluorine-Doped Diamond-Like Carbon Films Synthesized by Plasma Immersion Ion Implantation and Deposition (PIII-D), Applied Surface Science 230; pp. 172-178, 4/17/2004	
	C53	Bailey et al., Step and Flash Imprint Lithography: Defect Analysis, Journal of Vacuum Science, B 19(6), pp. 2806-2810, 11/1/2001	
	C54	Bailey et al., Step and Flash Imprint Lithography: Template Surface Treatment and Defect Analysis, Journal of Vacuum Science, B 18(6), pp. 3572-3577, 11/1/2000	
	C55	Schneider et al., Stripes of Partially Fluorinated Alkyl Chains: Dipolar Langmuir Monolayers	
	C56	Bender et al., Multiple Imprinting in UV-based Nanoimprint Lithography: Related Material Issues, Microelectronic Engineering 61 - 62, pp. 407 – 413, 1/1/2002	

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